



IFW

Docket No.: 0756-7263

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of )  
Shunpei YAMAZAKI, et al. )  
Serial No. 10/799,626 ) Group Art Unit: 2813  
Filed: March 15, 2004 ) Examiner: Laura Schillinger  
For: LASER IRRADIATION APPARATUS, LASER )  
IRRADIATION METHOD, AND METHOD FOR )  
MANUFACTURING A SEMICONDUCTOR DEVICE )

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria VA 22313-1450, on June 27, 2006

*Erin A. Huse*

**REQUEST FOR STATUS**

Honorable Commissioner of Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action on the amendment and response to the election requirement filed January 13, 2006 in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

*Eric J. Robinson*

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